

# Frequency Comparison of $^{127}\text{I}_2$ -Stabilized Nd:YAG Lasers

Feng-Lei Hong, Jun Ishikawa, Jun Yoda, Jun Ye, Long-Sheng Ma, and John L. Hall

**Abstract**— A first international comparison of  $\text{I}_2$ -stabilized Nd:YAG lasers has been made between the National Research Laboratory of Metrology (NRLM), Tsukuba, Japan, the Joint Institute for Laboratory Astrophysics JILA (formerly the Joint Institute for Laboratory Astrophysics), Boulder, CO, the National Institute of Standards and Technology (NIST), Boulder, and the University of Colorado, Boulder. The results of the comparison show that the square root Allan variance of the portable NRLM laser has reached  $2 \times 10^{-14}$  when the integration time is larger than 300 s. Matrix measurements were made for five hyperfine components from  $a_6$  to  $a_{10}$  of the R(56)32-0 line. The averaged frequency difference between the NRLM and JILA lasers for four measurements made on three separate days was  $-4996$  Hz (NRLM-JILA, at 532 nm) with a standard deviation of 88 Hz.

**Index Terms**— Frequency control, frequency stability, laser stability, neodymium:YAG lasers, spectroscopy, standards.

## I. INTRODUCTION

IODINE-STABILIZED Nd:YAG lasers are becoming important standards of wavelength and optical frequency, and the 1997 meeting of the CCDM (now CCL) has adopted the frequency value of the radiation of  $\text{I}_2$ -stabilized Nd:YAG lasers [1], [2] for the practical realization of the meter.  $\text{I}_2$ -stabilized Nd:YAG lasers have been studied by groups at Stanford University [3], [4] and the JILA (formerly the Joint Institute for Laboratory Astrophysics) [1], [2], [5]. The absolute optical frequency of the component  $a_{10}$  in the transition R(56)32-0 has been measured by the JILA group [1], [2].

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Recently, the JILA lasers have reached the unprecedented Allan frequency stability of  $5 \times 10^{-14}$  at 1 s, improving after 100 s toward a flicker floor at about  $5 \times 10^{-15}$  [6]. Research on  $\text{I}_2$ -stabilized Nd:YAG lasers is now being developed by metrological institutes in several countries.

Since many institutes conduct research on optical frequency standards, but very few have frequency chains to measure optical frequencies, it is very useful to have portable frequency-stabilized lasers, and to make comparisons between different countries. It was in this way that several unsuspected sensitivities and offsets were discovered for the 633 nm He-Ne/ $\text{I}_2$  system. In this paper, we report the results of the frequency comparison of  $\text{I}_2$ -stabilized Nd:YAG lasers between NRLM and JILA.

Due to the strong iodine transitions in the green and the high available laser power, there is no need for an intracavity setup or external buildup cavity for the iodine in the Nd:YAG laser case. This enriches the varieties of feasible  $\text{I}_2$ -stabilized Nd:YAG laser systems. For example, to reach ultimate stability and reproducibility of the system, the JILA laser has adopted a 1.2 m-long iodine cell, while the portable NRLM laser has contained a 30 cm-long iodine cell. It is very attractive to compare these lasers with different configurations, and to get some ideas for optimizing the system as a standard.

## II. LASERS AND EXPERIMENTAL CONDITIONS

The NRLM laser (NRLM-Y1) was fabricated in Japan and transported to JILA for frequency comparison. The laser control part and the final adjustment of the system are being finished at JILA. Fig. 1 shows the configuration of the portable NRLM laser. All the optical parts of the laser system were arranged on a 45 cm  $\times$  45 cm breadboard. The optical part of the system contains a source oscillator, a buildup cavity for second-harmonic generation (SHG), and an iodine spectrometer. The source oscillator of this system is a commercial diode pumped Nd:YAG laser, which emits about 700 mW at 1064 nm.

The SHG of the system is accomplished through the use of a ring buildup cavity with a nonlinear crystal of lithium triborate (LBO), which is operated at room temperature without temperature control. The cavity was controlled by two piezoelectric transducers (PZT's). One is a fast PZT with one single layer; the other is a slow PZT with multilayers. A dither at the frequency of 100 kHz was applied to the fast PZT to generate a cavity-locking signal. The fast and the slow servo signals were fed back to the fast and slow PZT, respectively. With a 7 mm-long LBO crystal, we could obtain 15 mW green light

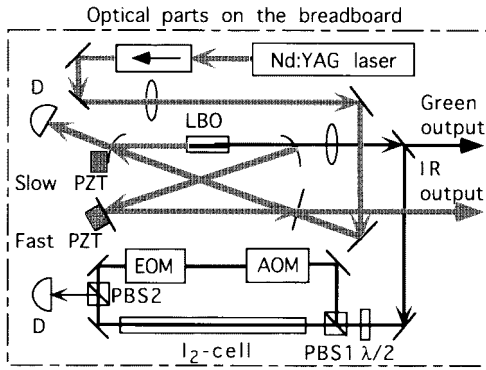


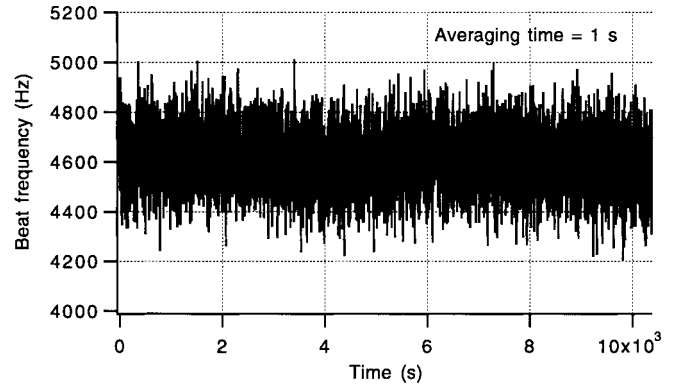
Fig. 1. Configuration of NRLM  $\text{I}_2$ -stabilized Nd:YAG laser: acoustooptic modulator (AOM); electro-optic modulator (EOM); polarization beamsplitter (PBS); and detector  $D$ .

from 525 mW IR input light, with a 20-fold cavity buildup. The reflected IR light from the cavity input coupling mirror is used as the IR output of the system.

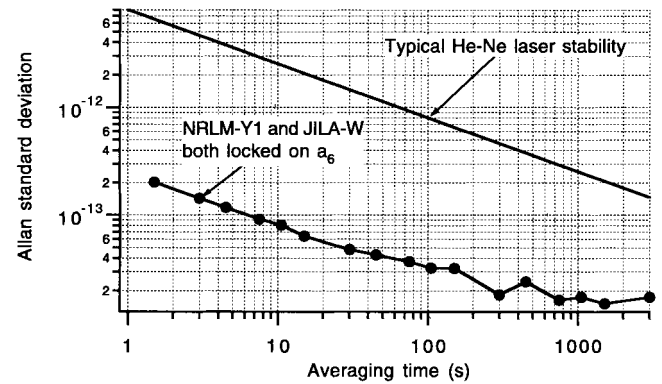
The iodine spectrometer (Fig. 1) contains a 30 cm-long iodine cell. The spectroscopy of molecular iodine was based on the sub-Doppler technique of modulation transfer [7], [8], which gives a nearly flat baseline and is therefore very attractive for laser spectroscopy and frequency stabilization. The pump beam was frequency-shifted by an acoustooptic modulator (AOM) and phase-modulated by an electrooptic modulator (EOM). The AOM worked as an optical isolator to prevent interferometric baseline noise problems in the iodine spectrometer. As shown in Fig. 1, the combination of a  $\lambda/2$  plate and a polarization beamsplitter (PBS1) was used to generate a proper power ratio for the pump and probe beams. To further reduce the interference between the linearly-polarized pump and probe beams, a crossed-polarization configuration was used allowing pump and probe beams to be separated by PBS2. Inside the iodine cell, both beams were overlapped with crossed polarization. The beams have a common waist near the cell's center and the Rayleigh range is 21 m.

A more detailed description of NRLM-Y1 is given in [9].

The frequency comparison was made between NRLM-Y1 and JILA-W lasers. To have both systems operated under the same conditions, the pressure of iodine in NRLM-Y1 was also adjusted to 0.79 Pa. This corresponds to a cold-finger temperature of the iodine cell of  $-15^\circ\text{C}$ . The pump beam power and the probe beam power of both lasers were 2.5 and 0.4 mW, respectively. The EOM modulation frequencies were 660 and 350 kHz for NRLM-Y1 and JILA-W, respectively. The AOM offset frequency of both lasers were near 80 MHz but slightly different one from the other. The AOM of JILA-W was adjusted to use the  $-1$  order diffracted beam, while the AOM of NRLM-Y1 was adjusted to use the  $+1$  order diffracted beam. This configuration is effective to avoid zero beating while both lasers are locked on the same hyperfine line. The heterodyne beat-note signal between the lasers was measured at 1064 nm (IR light) by using an avalanche photodetector. All the measured frequencies are converted to green light frequencies in this paper.



(a)



(b)

Fig. 2. (a) Variation of the measured beat-note frequency as a function of time. Drift of the optical frequency difference is  $<5$  mHz/s and (b) Allan standard deviation of the beat note between NRLM-Y1 and JILA-W (dot and solid line).

### III. COMPARISON RESULTS

#### A. Frequency Stability

Fig. 2(a) shows the time variation of the beat note between NRLM-Y1 and JILA-W when both lasers are locked on the  $a_6$  component of the R(56)32-0 line. Since the stability of JILA-W is fourfold better than that of NRLM-Y1 [6], the measurement results mainly indicate the stability of NRLM-Y1. The maximum frequency excursion of NRLM-Y1 in 10000 s was about 600 Hz. For application as an optical frequency transfer standard, the absence of long term drift [ $<5$  mHz/s for the data of Fig. 2(a)] is particularly welcome. Fig. 2(b) shows the Allan standard deviation of the measured beat frequency. The stability of NRLM-Y1 is  $2 \times 10^{-13}$  at 1 s, improving after 300 s toward the  $2 \times 10^{-14}$  level. Compared to typical  $\text{I}_2$ -stabilized He-Ne lasers, the portable  $\text{I}_2$ -stabilized Nd:YAG laser has reached a stability of about a factor of 35 better in the short-term region, and about one order of magnitude better in the long-term region.

#### B. Frequency Reproducibility and Repeatability

To determine the reproducibility and repeatability of frequency differences between the compared lasers, each laser in turn was stabilized to one of the hyperfine components  $a_6$ ,  $a_7$ ,  $a_8$ ,  $a_9$ , and  $a_{10}$  so that finally a five  $\times$  five matrix of measured frequency differences was obtained. These five

TABLE I

MATRIX MEASUREMENT (RUN #3). EACH BEAT RESULTS  $Bf$  (CORRESPONDING TO ONE ELEMENT IN THE MATRIX) CONSISTS OF THE AVERAGE OF TEN BEAT FREQUENCY DATA, WHERE EACH BEAT FREQUENCY DATA WAS MEASURED WITH A 10 s GATE TIME BY THE FREQUENCY COUNTER.  $Sdev$  IS THE STANDARD DEVIATION OF THE MEAN OF THE TEN MEASURED BEAT FREQUENCIES.  $\delta f$  IS THE FREQUENCY DIFFERENCE (NRLM-Y1 – JILA-W) WHEN EACH LASER WAS LOCKED ON THE SAME HYPERFINE COMPONENT OR WHEN THE HYPERFINE COMPONENT WAS EXCHANGED FOR EACH LASER

JILA-W NRLM-Y1		$a_6$	$a_7$	$a_8$	$a_9$	$a_{10}$
		$Bf$ (Hz)	4714	15 520 120	38 153 410	53 869 930
$a_6$	$Sdev$ (Hz)	34	38	40	38	36
	$\delta f$ (Hz)	-4714	-4602	-5041	-5229	-4773
$a_7$	$Bf$ (Hz)	15 510 916	4526	22 637 752	38 354 298	154 553 080
	$Sdev$ (Hz)	38	38	30	40	32
	$\delta f$ (Hz)		-4526	-4937	-5138	-4677
$a_8$	$Bf$ (Hz)	38 143 328	22 627 878	5338	15 721 894	131 920 630
	$Sdev$ (Hz)	32	46	24	36	28
	$\delta f$ (Hz)			-5338	-5545	-5068
$a_9$	$Bf$ (Hz)	53 859 472	38 344 022	15 710 804	5800	116 204 492
	$Sdev$ (Hz)	42	42	26	44	48
	$\delta f$ (Hz)				-5800	-5271
$a_{10}$	$Bf$ (Hz)	170 059 174	154 543 726	131 910 494	116 193 950	4782
	$Sdev$ (Hz)	30	42	42	34	30
	$\delta f$ (Hz)					-4782

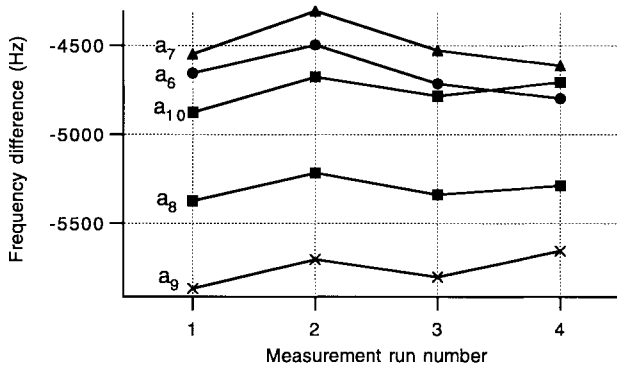


Fig. 3. Frequency differences of NRLM-Y1 and JILA-W when each laser was locked on the same hyperfine line (the diagonal components of the matrix measurements).

lines were chosen because they are located near the Doppler center and have no strong lines nearby.

Table I shows a typical measured matrix (Run #3). Each beat result ( $Bf$ ) (corresponding to one element in the matrix) consists of the average of ten beat frequency data, where each beat frequency data was measured with a 10 s gate time by the frequency counter.  $Sdev$  is the standard deviation of the measured beat frequency data. The typical value of  $Sdev$  is 40 Hz.  $\delta f$  is the frequency difference (NRLM-Y1–JILA-W) when each laser was locked on the same hyperfine component or when the hyperfine component was exchanged for each laser. The averaged  $\delta f$  of matrix measurement (Run #3) is  $-5029$  Hz with a standard deviation of 365 Hz. Fig. 3 shows, for four measurements made on three different days, the frequency differences of NRLM-Y1 and JILA-W when each laser was locked on the same hyperfine line (the diagonal components of the matrix measurements). A pattern has been formed by the diagonal components, and been repeated during the four measurements. This means the two systems effectively have different hyperfine splittings at some small level. With the higher stability of these 532 nm systems, as compared

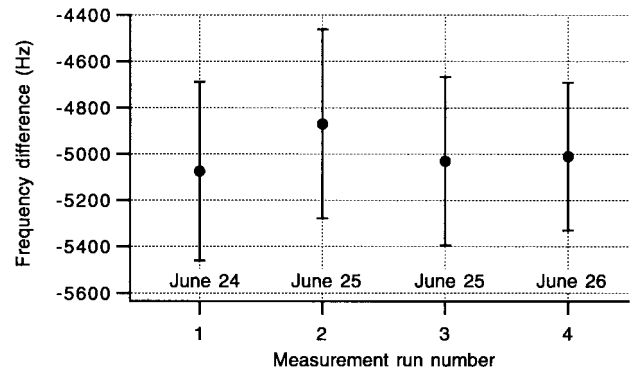


Fig. 4. Repeatability of the matrix-averaged frequency differences between lasers NRLM-Y1 and JILA-W. The uncertainties are given as one standard deviation of the matrix averaging.

to He–Ne lasers, we can now look into these issues more precisely. So, once again, this international intercomparison has turned up some otherwise unexpected physical effects.

Because of the hyperfine-structure dependencies, the frequency difference between the two systems will be calculated here using the matrix method. Fig. 4 shows the matrix-averaged results of the four frequency comparisons. This averaged frequency difference between the NRLM and JILA lasers for the four measurements was  $-4996$  Hz with a standard deviation of 88 Hz. The origin of the observed frequency difference of the two systems may also be partly associated with the difference of the hyperfine splitting. The uncertainties in Fig. 4 are given as one standard deviation of the matrix averaging. It is important to gain a deeper understanding of the nearly tenfold ratio of the matrix-averaged standard deviation and that of each single beat measurement.

### C. Frequency Shifts

Pressure shift and power shift of the locking frequency were measured for NRLM-Y1 to reveal the frequency shifts due to the changing of cold-finger temperature or of laser power.

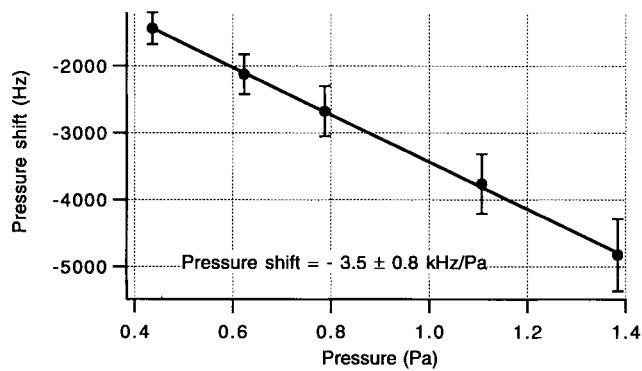


Fig. 5. Pressure shift of NRLM-Y1. Averaged value for  $a_6$  to  $a_{10}$  hyperfine components of R(56)32-0. The uncertainties are given as one standard deviation of the averaging.

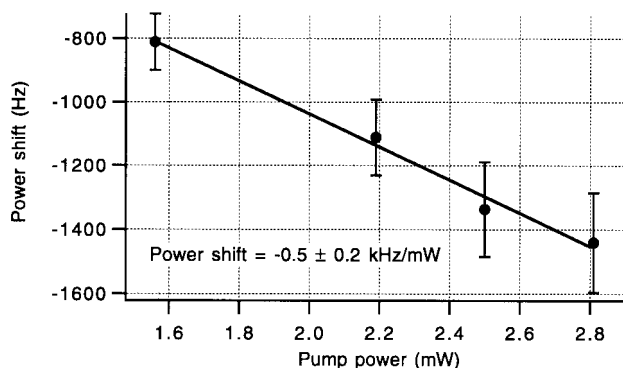


Fig. 6. Power shift of NRLM-Y1. Averaged value for  $a_6$ – $a_{10}$  hyperfine components of R(56)32-0. The uncertainties are given as one standard deviation of the averaging.

Fig. 5 shows the measured pressure shift of NRLM-Y1 with the averaged value for  $a_6$  to  $a_{10}$  components. The uncertainties are given as one standard deviation of the averaging. The power of the pump and probe beams of NRLM-Y1 was kept at 2.5 and 0.4 mW, respectively. The measured pressure shift slope was  $-3.5 \pm 0.8$  kHz/Pa. This is about two times larger compared to the reported pressure shift of the JILA laser [5].

Fig. 6 shows the measured power shift of NRLM-Y1 with the averaged value for  $a_6$  to  $a_{10}$  components. The uncertainties are given as one standard deviation of the averaging. The cold-finger temperature of NRLM-Y1 was kept at  $-15$  °C. The measured power shift slope was  $-0.5 \pm 0.2$  kHz/mW. This slope has an opposite sign compared to the reported power shift of the JILA laser [5]. The difference of the pressure and the power shifts of the NRLM and JILA lasers also are related to the observed frequency difference, since the frequency difference is taken at some convenient operating point, as opposed to being an extrapolation to zero pressure and power.

#### IV. CONCLUSIONS

We have fabricated a portable  $\text{I}_2$ -stabilized Nd:YAG laser for international frequency comparisons. The results of the comparison between this laser and the JILA-W standard show that the stability of the portable laser has reached  $2 \times 10^{-14}$  when the integration time is larger than 300 s. The matrix measurements of five hyperfine lines made on three different days show that the average frequency difference between JILA-W

and the portable NRLM-Y1 was  $-4996$  Hz (NRLM-JILA, at 532 nm) with a standard deviation of 88 Hz. The repeatability of the frequency measurement has reached 51 Hz, which is the average standard deviation for the four measurements.

Frequency differences can arise from differing saturation parameters, residual linewidths and possible (small) contamination of the  $\text{I}_2$  reference cells. The wavefront difference of the overlapping beams inside the iodine cell may also cause frequency shifts [10]. Independent adjustment of these items will be reconfirmed. Also, frequency comparisons involving more than two  $\text{I}_2$ -stabilized Nd:YAG lasers may give us a more clear description for each system, and are now in progress.

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